AUTHOR:	R. J. CENCE	DATE: 7/	5/83 REPLACES CI
TITLE:	MASK LOCATIONS IN 1	NE SLC FINAL FOCUS R	EGION DE84 0
In this is to shield an heavily on the Note CN \$53 point of this count the re For the latest design assum point and that placed about design are sho	brief note we describe gainst backgrounds in t e earlier work of E.S. entitled "Background note is to update the ecent changes that have t beam design we use th nes that the final be t the final quadrupoles 8 feet from the intera own in Fig. 1.	the location of four the final focus region Miller and J.C. So at the SLC Interac- results of Miller and been made in the op e TRANSPORT output of nds will form an 'S' will be supercond ction point. Some of	sets of masks needed a of the SLC. We rely ens in SLC Workshop ction Point." The main d Sens taking into ac- tics of the SLC beams. dated 5-13-83. This about the interaction ducting and will be f the features of this
The only detector. Th This backgrour further here. tector to redu	serious backgrounds ar ne neutrons are produce nd is adequately discus Concrete shielding nce this background.	e due to photons and d by bremsstrahlung p sed in CN #53 and wij can be placed over ti	neutrons entering the botons hitting masks. Il not be considered he end caps of the de-
Virtually beamsstrahlung synchroton rad produced by minor backgrou COLLIDER CONC AATF/80/22. T backgrounds w below. Each o turn.	all the photon ba produced by the b liation produced by the the final superconduct ands which are discussed EPTUAL DESIGN REPORT hese will not be consid hich will not affect f the three main photor	ckgrounds come fr eams interacting at t soft bends, and s ting quadrupoles. Th d by Miller and Sens, (SLAC-Report-229), dered here. In gene t the design of the backgrounds will be	com three sources: the interaction point, synchrotron radiation ler are several other , by the SLAC LINEAR and by J. Jaros in aral they are minor masks to be discussed a now be considered in
BEAMSSTRA produces a p form in direct these photons enough distance If the quadre and the beam p amsstrahlung w ft. from the of aluminum fo	HLUNG. The interaction hoton beam with a maxim ion within a maximum an be allowed to leave e so that backscatterin upoles located at 60-9 ipe is allowed to incre ill not hit anything un interaction point. Thi Llowed by about 20 or s	n of the beams at the num critical energy of agle of 2.2 mr. It the detector region is into the detector 20 ft on Fig. I have ease in size as indic itil it reaches hask is Mask is made up of so radiation lengths	the interaction point of about 300 MeV, uni- is important that unimpeded for a great is kept to a minimum. an aperture of 5 In. ated, then the be- 0 at a distance of 95 2 radiation lengths of lead.
To keep th Mask 0, the di interaction point that the fina ilso. (This is plane of the fi	he beamsetrahlung from lameter of the beam pip int. Beyond Mask O a 2 al soft and hard bend a not shown in Fig. 1 lgure.)	hitting the beam pip- e must be 5 in. from on diameter is suff magnets need have ap- since the pole tips a	e before it reaches m 20' to 95' from the icient. This means ertures of only 2 cm, are actually in the
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The characteristics of the backscattering were studied using the program EGS. (We thank Ralph Nelson for helping us run his program.) The most important result obtained from EGS is that the number of backscattered photons at 180 deg per incident photon per unit solid angle lies in the range 0.2-0.4. This result is valid for incident photons in the energy range 50-300 MeV and for absorbers between aluminum and lead with lighter elements tending to have a lower value.

The most important difference between aluminum and lead lies in the energy spectrum of the backscattered photons. This is shown in Fig. 2. For aluminum the energy spectrum peaks near 100 KeV, whereas, for lead the energy spectrum peaks near 500 KeV. The purpose of Mat 0 shown in Fig. 1 is to absorb this beamsstrahlung. Fig. 3 shows the immediate region around the interaction point including Masks 2 and 3. The aperture in Mask 3 assumes that the detector subtends all angles to within 30 mr of the beam direction. In order to calculate the number of photons inciden on the detector due to the backscattered photons from the beamsstrahlung dump se need to calculate the solid angle of the aperture in Mask 3, partially shielded by Mask 2 from a uniform extended source, Mask 0. For the geometry shown in Fig. 3 a Monte Carlo calculation gives for the solid angle,

$\Delta\Omega/2\pi = 0.04 \times 10^{-9}$

Assuming that the average fractional energy lost by an electron is 0.5×10^{-3} , 300 MeV maximum critical energy, 5×10^{10} electrons er beam, and the above solid angle, then the number of beamsstrahlung backscattered photons into the detector would be ~1 per crossing. This rate is very sensitive to the location and size of mask 2.

SOFT BEND SYNCHROTRON RADIATION. In order to reduce the critical energy the final hard bend is followed by a final soft bend. The parameters of these bends are listed below:

BEND	ANGULAR BEND	RADIUS OF CURV.	CRITICAL ENERGY	PHOTONS/ELECTRON
Hard	0,903 deg	507 ft.	1.80 MeV	16.3
Soft	0.144 deg	10,944 ft.	0.084 MeV	2.6

For the above parameters we find that approximately 10 photons/crossing will enter the detector due to fluorescence from the inner side of Mask 2 with the geometry of Fig. 3. (Photons emerging from the inner side of Mask 2 must rescatter off Mask 3 in order to enter the detector.) This represents about 40 soft photons/meter² on the inner face of the drift chamber. If Mask 3 is closed down so that the minumum angle of the detector is 200 mr, then the aperture in Mask 3 is reduced from 4 ft. to 1 ft. The background of soft photons from the inner side of Mask 2 becomes 20/crossing, or 7/meter² on the inner face of the drift chamber.

To calculate the number of photons incident on the secondary vertex detector we assume a length of 4 cm and an inner radius of 1.5 cm. These values come from a very preliminary design using silicon strips. In contrast to the drift chamber the vertex detector is not shielded by mask 3. However, back-

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grounds are still small due to its small size and mass. We expect about 30 photons/crossing incident on this detector due to fluorescent photons from soft bend synchrotron radiation on the inner size of Mask 2.

QUADRUFOLE SYNCHROTRON RADIATION. The most serious background for a small angle detector is due synchrotron radiation from the final quadrupoles. These are assumed to be superconducting as in the most recent beam optics design. This radiation is most intense along the beam axis which means that this background <u>increases</u> as the aperture in Mask 2 is <u>decreased</u> due to fluorescence produced by the synchrotron radiation incident on the inner side of Mask 2. The precise amount of background from this source depends sensitively on the location and aperture in the two Masks 2. The minimum aperture is determined by the 2.2 m maximum angle of the beamsstrahlung. In Fig. 3 we show an aperture with radius 0.7 cm which is about 0.2 cm outside the maximum angle of the beamsstrahlung. The location and aperture of Masks 2 needs further tuning using detailed tracing of electrons thru the quadrupoles. Hobey DeStaebler at SLAC is working on this and will distribute results as soon as they are available.

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HORIZONTAL CROSS SECTION

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